IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appln. No:

To be assigned

Applicant:

Hidenobu HAMADA

Filed:

Herewith

Title:

OPTICAL DEVICE, AND PRODUCTION METHOD FOR PHOTONIC CRYSTAL

SLAB

TC/A.U.: Examiner:

Confirmation No.:

Docket No.:

MTS-3606US

INFORMATION DISCLOSURE STATEMENT

Mail Stop PCT Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

SIR:

Pursuant to 37 C.F.R. §§ 1.97 and 1.98 and to the duty of disclosure set forth in 37 C.F.R. § 1.56, the Examiner in charge of the above-identified application is requested to consider and make of record the references listed on the PTO/SB/08a and /08b submitted herewith. Copies of the references listed are enclosed.

Although the information submitted herewith may be "material" to the Examiner's consideration of the subject application, this submission is not intended to constitute an admission that such information is "prior art" as to the claimed invention.

In accordance with 37 C.F.R. § 1.97(g), the filing of this Information Disclosure Statement shall not be construed to mean that a search has been made.

The following references are not in the English language:

- 1) JP 2003-240989
- 2) JP 2002-365599
- 3) JP 2001-272566
- 4) JP 9-5549
- 5) JP 6-222234
- 6) JP 2004-086070

P20 Recid PCTPTQ zo JUL 2006

7) JP 2001-091701

8) JP 2001-337236

References 1) to 6) were cited in a search report by a foreign Patent Office in a patent application corresponding to the above-identified patent application. A copy of this search report, which indicates the degree of relevance found by the foreign office, is transmitted herewith.

References 6) to 8) include an English language Abstract.

This Information Disclosure Statement is being filed concurrently with the abovereferenced application.

Respectfully submitted,

RatherPrestia

Ĺawrence E. Ashery, Reg. No,∕34,515

Attorney for Applicant

LEA/bj

Enclosures: PTO/SB/08a and /08b

11 References Search Report

Dated: July 20, 2006

The Commissioner for Patents is hereby authorized to charge payment to Deposit Account No. 18-0350 of any fees associated

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I hereby certify that this paper and fee are being deposited, under 37 C.F.R. § 1.10 and with sufficient postage, using the "Express Mail Post Office to Addressee" service of the United States Postal Service on the date indicated above and that the deposit is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Dennis McDermott

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use as many sheets as necessary)

SHEET 1 of 2

Complete if Known			
Application Number	To be assigned		
Filing Date	Herewith		
First Named Inventor	Hidenobu HAMADA		
Art Unit			
Examiner Name			
Attorney Docket No.	MTS-3606US		

U.S. PATENT DOCUMENTS					
		Document Number			Pages, Columns, Lines, Where
Examiner Initials*	Cite No. ¹	Number - Kind Code ^{2 (if known)}	Publication Date (MM-DD-YYYY)	Name of Patentee or Applicant of Cited Document	Relevant Passages or Relevant Figures Appear
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FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No.1	Foreign Patent Document Country Code ³ - Number ⁴ - Kind Code ^{5 (If known)}	Publication Date (MM-DD-YYYY)	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T⁵
		JP 2003-240989	08-27-2003	Matsushita Electric Industrial Co., Ltd.		
		JP 2002-365599	12-18-2002	Agilent Technologies Inc.		
	1	JP 2001-272566	10-25-2001	Minolta Col, Ltd.		
		JP 9-5549	01-10-1997	Sumitomo Electric Industries, Ltd.		
		JP 6-222234	08-12-1994	Osaka Gas Col, Ltd.		
,		JP 2004-086070 (w/English Abstract)	03-18-2004	Matsushita Electric Industrial Co., Ltd.		
		JP 2001-091701 (w/English Abstract)	04-06-2001	Kawakami Shojiro Autocloning Technology:KK		
		JP 2001-337236	12-07-2001	Nippon Telegr & Teleph Corp.		

Examiner	Date	$\overline{}$
Signature	Considered	

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¹Applicant's unique citation designation number (optional).

²See Kind Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04.

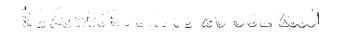
³Enter Office that issued the document, by the two-letter code (WIPO Standard St.3).

⁴For Japanese patent documents, the indication of the year of the Emperor must precede the serial number of the patent document.

⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible.

Applicant is to place a check mark here if English language translation is attached.

The collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.



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SHEET 2 of 2

Complete if Known			
Application Number	To be assigned / OZA		
Filing Date	Herewith 20032U		
First Named Inventor	Hidenobu HAMADA		
Art Unit			
Examiner Name			
Attorney Docket No.	MTS-3606US		

NON-PATENT LITERATURE DOCUMENTS				
Examiner Initials*	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published	T²	
		M.D.B. CHARLTON et al., "GUIDED MODE ANALYSIS, AND FABRICATION OF A 2-DIMENSIONAL VISIBLE PHOTONIC BAND STRUCTURE CONFINED WITHIN A PLANAR SEMICONDUCTOR WAVEGUIDE," Materials Science & Engineering B49, 1997, pp 155-165, Vol. 49, No. 2, Elsevier Science S.A., USA		
		STEVEN G. JOHNSON et al., "GUIDED MODES IN PHOTONIC CRYSTAL SLABS," Physical Review B, 1999, pp 5751-5758, Vol. 60, No. 8, The American Physical Society, USA		
		CLAUDE WEISBUSH et al., "3D CONTROL OF LIGHT IN WAVEGUIDE-BASED TWO-DIMENSIONAL PHOTONIC CRYSTALS," IEICE Trans. on Electronics, 2001, pp 660-668, Vol E84-C, No. 5.		
		International Search Report for corresponding International PCT Application No. PCT/JP2004/018509 dated March 29, 2005.		

Examiner	 Date	
Signature	Considered	

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